

09/450685

ABSTRACT

5 A mini-environment pod device for a micro-device
manufacturing apparatus includes a cassette being able to
hold a plurality of wafers, a pod providing an inner space
to store the cassette, wherein the pod includes an
electromagnetic shield, and a lid which fits into an
opening of the pod. The lid provides an isolated
environment in the inner space. When the mini-environment
pod is installed on the manufacturing apparatus, the
electromagnetic shield is in a conductive relationship
10 with a shielded chamber of the manufacturing apparatus.

SECRET 03903450